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3-22-02

00862.022453.1

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
	:	Examiner: Unassigned
Kenichi KOTOKU	)	
	:	Group Art Unit: 2812
Application No.: 09/960,694	)	
	:	
Filed: September 24, 2001	)	
	:	
For: EXPOSURE APPARATUS AND	)	January 3, 2002
SEMICONDUCTOR DEVICE	:	
MANUFACTURING METHOD	)	

Commissioner for Patents  
Washington, D.C. 20231

RECEIVED  
MAR 20 2002  
TC 1700

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed PTO-1449 form. Copies of the listed documents are also enclosed.

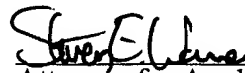
Japanese patent document 62-176129 and U.S. Patent No. 4,095,891 are discussed on page 2 of the subject application. U.S. Patent No. 4,711,568 corresponds to the '129 document.

This Information Disclosure Statement is being filed before the issuance of a first Office Action on the merits. Therefore, no fee under 37 C.F.R. 1.97(c)(2) is believed due. Nevertheless, the Commissioner may charge Deposit Account No. 06-1205, should any fee be due for filing this paper.

Applicant requests that the above information be considered by the Examiner and that a copy of the enclosed PTO-1449 form be initialed and returned indicating that such information has been considered.

Applicant's undersigned attorney may be reached in our Washington D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

  
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